

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

EXPRESS MAIL NO. EV327880615US

Appl No. : N/A Confirmation No.
Applicant : Naoya Takeuchi
Filed : February 17, 2004
Title : PATTERN INSPECTION METHOD AND APPARATUS

TC/A.U. : N/A
Examiner : N/A

Docket No. : 51971/DBP/A400
Customer No. : 23363

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
February 17, 2004

Commissioner:

Prior to examination, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.